



Att. Docket No. 10191/2262

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. Serial No. : 10/070,286 Confirmation No. 3055
Title : METHOD FOR PRODUCING A SEMICONDUCTOR
COMPONENT AND A SEMICONDUCTOR COMPONENT
PRODUCED ACCORDING TO THE METHOD

OK
to
enter
file
6/17/05

Applicant(s) : Hubert Benzel et al.
Filed : July 8, 2002
TC/A.U. : 1765
Examiner : Anita Karen Alanko
Docket No. : 10191/2262
Customer No. : 26646

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AARON C. DEDUTCH
(33,865)

AMENDMENT AFTER A FINAL OFFICE ACTION

S I R:

In response to the Final Office Action mailed on February 24, 2005 (the three-month response date for which is May 24, 2005), please reconsider the above-identified application based on the following:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of the claims which begins on page 3 of this paper.

Remarks begin on page 6 of this paper.